



Docket No. 740756-2317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Hajime KIMURA ) Group Art Unit: 2615  
Application No. 09/864,280 ) Examiner: Lin Ye  
Filed: May 25, 2001 ) Confirmation No. 1263  
For: MOS SENSOR AND DRIVE METHOD ) Date: August 15, 2005  
THEREOF

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 13, 2005, please consider the amendments and remarks in connection with the above-identified application as follows.

*Please*

*Enter!*

*WJ*

*8/30/05*